

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

MAEDA et al

Serial No.: 09/808,016

Filed: March 15, 2001

For: FILM-FORMING SURFACE
REFORMING METHOD AND
SEMICONDUCTOR DEVICE
MANUFACTURING METHOD



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) Art Unit: 2829
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) Examiner: Kilday
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RESPONSE TO OFFICE ACTION OF JUNE 5, 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Responsive to the office action of June 5, 2003, please amend the captioned application
as follows: